

<b>Search Notes</b> 	<b>Application/Control No.</b>	<b>Applicant(s)/Patent under Reexamination</b>
	10/043,066	BISSEN, DAVID R.
	<b>Examiner</b>	<b>Art Unit</b>
	Korie H. Chan	3632

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner